Electronic Acknowledgement Receipt				
EFS ID:	1123765			
Application Number:	09888222			
Confirmation Number:	7524			
Title of Invention:	Japanese language entry mechanism for small keypads			
First Named Inventor:	Samuel Yin Lun Pun			
Correspondence Address:	James D. Ivey Law Offices of James D. Ivey 3025 Totterdell Street - Oakland CA 94611-1742 US -			
Filer:	James D. Ivey			
Filer Authorized By:				
Attorney Docket Number:	P-2177			
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Application Type:	Utility			
International Application Number:				
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## Payment information:

Submitted with Payment	no	
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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Transmittal letter	transmittal.pdf	189406	no	1
Warnings:		1	1		
Information:					
2	Amendment - After Non-Final Rejection	Response_OA.pdf	157040	no	14
Warnings:		1			
Information:					
		Total Files Size (in bytes):	34	346446	

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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.